

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Substitute for form 1449/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	10/558,438
Sheet	1	of	3	Filing Date	March 19, 2007
				First Named Inventor	LEE, Koon-Seok
				Art Unit	2477
				Examiner Name	Daniel D. Mitchell
				Attorney Docket Number	7950.046.00

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.	Document Number Number/Kind Code* (If known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
AA	2001/0025322 A1	09-27-2001	Song et al.		
AB	2002/0035624 A1	03-21-2002	Kim et al.		
AC	2002/0165989 A1	11-07-2002	Etoh		
AD	2003/0051053 A1	03-13-2003	Vasko et al.		
AE	2003/0051203 A1	03-13-2003	Vasko et al.		
AF	2003/0079001 A1	04-24-2003	Chamberlain		
AG	2003/0165142 A1	09-04-2003	Mills et al.		
AH	2004/0042487 A1	03-04-2004	Ossman		
AI	2004/0064578 A1	04-01-2004	Boucher et al.		
AJ	2004/0088731 A1	05-06-2004	Putterman et al.		
AK	2005/0108568 A1	05-19-2005	Bussiere et al.		
AL	2006/0248518 A1	11-02-2006	Kundert		
AM	2006/0271709 A1	11-30-2006	Vasko et al.		
AN	2008/0097631 A1	04-24-2008	Baek et al.		
AO	2008/0259786 A1	10-23-2008	Gonda		
AP	6,058,106	05-02-2000	Cudak et al.		
AQ	5,835,723	11-10-1998	Andrews et al.		
AR	6,631,476 B1	10-07-2003	Vandesteeq et al.		
AS	6,701,198 B1	03-02-2004	Vandesteeq et al.		
AT	6,721,900 B1	04-13-2004	Lennen et al.		
AU	6,842,430 B1	01-11-2005	Melnik		

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No.	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code* Number/Kind Code* (If known)			
BB	1020010093265 A		10-27-2001	Samsung Electronics Co., Ltd.	Abstract

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. *Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the parent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No.*	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional) ²Applicant is to place a check mark here if English language Translation is attached

Examiner Signature	/Daniel Mitchell/	Date Considered	01/28/2011
--------------------	-------------------	-----------------	------------

DC-50667049.1

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /D.M./